IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/050,334
Filing Date ....January 15, 2002
Inventor ....Vishnu K. Agarwal
Assignee...Micron Technology, Inc.
Group Art Unit 2813
Examiner...Tuan H. Nguyen
Attorney's Docket No. MI22-1913
Title: Capacitor Fabrication Methods and Capacitor Constructions and
     Enhanced Surface

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
References – See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is

directed to the United States patents and other references listed on the attached

Form PTO-1449. No admission is made regarding whether all the submitted

references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: ___14 Feb 2006___   By: _____
                                James E. Lake
                                Reg. No. 44,854

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1913		SERIAL NO. 10/050,334	
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT: Vishnu K. Agarwal			
				FILING DATE January 15, 2002		GROUP 2813	

U.S. PATENT DOCUMENTS

*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	2005/0082593 A1	04/2005	Lee et al.			
	AB	2003/0215960	11/2003	Mitsuhashi			
	AC	6,824,816	11/2004	Aaltonen et al.			
	AD	6,307,730	10/2001	Yamanishi			
	AE	6,800,892	10/2004	Bhattacharyya			
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	No
	AJ							
	AK							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AM		
	AN		
	AO		

EXAMINER		DATE CONSIDERED	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.